

Search Notes

Application No.

10/032,838

Examiner

Kuo-Liang Peng

Applicant(s)

FERM ET AL.

Art Unit

1712

SEARCHED

Class	Subclass	Date	Examiner
427	387	9/2/2003	KLP
427	508		
428	429		
428	421		
428	448		
428	451		
428	688		
428	500		
428	447		
528	32		
528	39		
528	41		

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
427	387, 508	9/2/2003	KLP
428	429, 421		
428	448, 451		
428/688, 500, 447 528/32, 39, 41			

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
semiconductor or silicon\$ adj wafer, Silicone adj dioxide	9/2/2003	KLP
Tetraethylorthosilicate, 3- aminopropyltriethoxysilane		
3- methacryloyloxypropyltrimethoxysilane or 3- methacryloyloxypropyltriethoxysilane		
vinyltrimethoxysilane or vinyltriethoxysilane or organosilane		
(Fluorinated or flurine) adj3 (acrylate or methacrylate or meth! Adj acrylate)		
Alkoxy or Alkoxysil\$3 or SiOR or Si adj ("OR.sub."\$9 or "OR.Sup."\$3) or SiOR\$3 or silyl adj ester or hydrocarbonoxy		
RTV or (room adj temperature or moisture) with (cure or curing or cured or curable)		
EAST, Inventor name search on PALM		